



Precompensation of gain nonuniformity in a Nd:glass amplifier using a programmable beam-shaping system

S.-W. Bahk*, I.A. Begishev, J.D. Zuegel

Laboratory for Laser Energetics, University of Rochester, 250 East River Road, Rochester, NY 14623, United States

ARTICLE INFO

Article history:

Received 19 June 2014

Received in revised form

17 July 2014

Accepted 20 July 2014

Available online 31 July 2014

Keywords:

Beam shaping

Spatial light modulator

Laser amplifier

Optical parametric chirped pulse amplification

Nd:glass

High energy laser

ABSTRACT

A programmable liquid crystal beam-shaping system was installed for a 200-mJ optical parametric chirped-pulse amplification (OPCPA) system front end and was applied to dramatically improve the beam uniformity in the subsequent amplifier. A highly nonuniform beam profile caused by gain inhomogeneity in the amplifier was pre-compensated by the beam shaping system using significantly improved open-loop and closed-loop algorithms. The details of the improved algorithms will be described. The issues of running a liquid crystal device with a high-energy, ultrashort-pulse laser, such as damage risk and temporal contrast degradation, will be addressed.

© 2014 Elsevier B.V. All rights reserved.

1. Introduction

A dynamic beam-shaping system using a liquid crystal spatial light modulator (SLM) has undergone a successful transition from initial proof-of-principle demonstrations [1,2] to an implementation in a high-energy laser such as the OMEGA EP at the University of Rochester [3]. The operation principle of the beam-shaping system is based on the phase-only carrier method, which enables one to have arbitrary two-dimensional (2-D) control of both the laser-beam fluence and the wavefront by adjusting the modulation depth and the bias of the carrier phase. A liquid crystal on silicon (LCOS) SLM can be used to create a programmable high-frequency carrier phase. Closed-loop operation of such a device paired with feedback from a near-field camera or a wavefront sensor dramatically improves the performance [2].

Gain precompensation [4] and spot shadowing [5,6] are important applications of a dynamic beam shaper in high-energy lasers. The precompensation of gain inhomogeneity in amplifiers reduces the peak-to-mode in fluence distribution in such a way that the total energy of the beam can be increased without risking damage to the optics. The gain precompensation in OMEGA EP long-pulse (ns) beamlines is achieved in multiple steps using both static and dynamic beam shapers [3,7]. The dynamic beam shaper is located in the low-energy front end, where a residual 2-D correction map

is applied to improve the overall system gain precompensation performance and the uniformity of the final output beam. A similar gain precompensation experiment was performed in another facility for a Nd:glass amplifier but with insignificant improvement in beam uniformity [8].

In this paper we present a more-challenging application of dynamic beam shaping in the context of a 50-J, 700-fs optical parametric chirped-pulse amplification (OPCPA) system. The high degree of gain saturation in the optical parametric amplification (OPA) crystals precludes the possibility of installing the SLM before the OPA. The incident beam energy on an SLM installed after the OPA is high enough, however, to damage the device if not carefully managed. Pulse contrast degradation caused by the secondary reflection from the front surface of the SLM cover glass is a non-negligible problem in this pulse-width regime. It introduces a prepulse 30-ps before the main pulse. We have been able to mitigate or remove these problems. The details of our approach will be described later.

Significant improvements and diversifications in the algorithms and the mode of operations of the carrier method have been made. First, a large discrepancy was found between the analytic transmission function derived in [1] and the experimental function. An empirical formula is introduced here that agrees better with the measurements. It greatly improves the accuracy of the open-loop algorithm. The closed-loop algorithm introduced in [2] is based on incrementing or decrementing a fixed unit-step size of the digital command map. It can be inefficient to use a fixed step size where many steps are required for convergence. A more-efficient closed-loop algorithm will be discussed.

* Corresponding author.

E-mail address: sbah@le.rochester.edu (S.-W. Bahk).

The type of carrier used in the carrier beam-shaping method is not limited to a one-dimensional (1-D) rectangular carrier. A checkerboard-pattern carrier was successfully used in the laser-cavity mode shaping in [9]. The choice of the transmitted diffraction order does not need to be the zeroth order. A sawtooth-shaped carrier beam can maximize the diffracted energy into the first-order diffraction term, where the first-order term is chosen to be the main transmitted beam. Such mode of operation is fail-safe since the beam can propagate only in the presence of a carrier.

Improvements to the carrier beam-shaping algorithms will be discussed followed by detailed descriptions of the laser system and the experimental results.

2. Improvement and diversification of the original carrier beam shaping method

In the original phase-only carrier beam-shaping method, a rectangular carrier phase is applied to an SLM. A beam incident on the SLM acquires high-frequency modulation in phase and diffracts into the zeroth- and first-order diffractions. As the modulation peak-to-valley (p-v) approaches π , more energy diffracts into the first- and higher-order diffractions. The diffracted beams are filtered and only the zeroth-order beam is allowed to pass. In this way the intensity transmission factor can be adjusted by controlling the modulation depth of the carrier phase. A 2-D transmission map as a function of carrier amplitude can be generated to achieve a desired beam shape. This principle can be modified in such a way that the first-order diffraction beam passes, whereas the zeroth-order beam is blocked. The benefit of such a configuration is that the beam does not propagate when the SLM fails to introduce the carrier, which is a useful feature for fail-safe operation in a high-energy laser. The disadvantage is that the maximum transmission cannot exceed 50% because the first-order diffractions are equally split. The low efficiency can be improved by using a sawtooth carrier phase (blazed grating) instead of a rectangular one. The diffraction efficiency of the first-order diffraction for the sawtooth carrier phase can be very high. These two modes of operation are schematically shown in Fig. 1, where Fig. 1 (a) describes the original carrier beam-shaping setup and Fig. 1 (b) shows the modified carrier method in Littrow configuration. We refer to the first configuration as the normal mode and the second one as the diffractive mode. For later discussions, the transmission $[T(x,y)]$ of a carrier method in the near field of each setup after filtering is defined as

$$T(x,y) = \frac{E_{0\text{th order}}(x,y)}{E_{\text{inc}}(x,y)}, \quad (1)$$

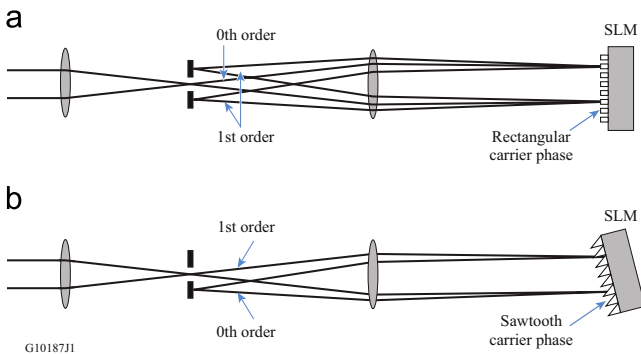


Fig. 1. Two modes of carrier-beam shaping: (a) normal mode using the zeroth-order beam as the main beam; (b) diffractive mode using the first-order beam as the main beam.

and

$$T(x,y) = \frac{E_{1\text{st order}}(x,y)}{E_{\text{inc}}(x,y)}, \quad (2)$$

for normal- and diffractive-mode methods, respectively. E_{inc} is the incident local energy on the SLM, and $E_{0\text{th order}}$ and $E_{1\text{st order}}$ are the local reflected energy contained in the zeroth- and the first-order diffraction beam, respectively.

2.1. Improvement in the open-loop algorithm

The algorithm described here assumes using an LCOS-SLM device whose voltage-to-phase-retardation response is linearized by using a look-up-table (LUT). Use of an LUT does not completely remove the small variations in phase retardation in individual pixels of an SLM. In our case, the variation is $\pm 6\%$. In an open-loop algorithm, we attempted to achieve the best beam-shaping performance in a single step, neglecting these small variations. We used a reflective LCOS-SLM from Hamamatsu (X10468-03). The phase of an individual pixel is controlled by applying voltage on the nematic liquid crystal sandwiched between two parallel-aligned alignment layers. The SLM has 600×800 20- μm pixels over a 12×16 -mm² area. A phase retardation from 0 to 2 waves can be independently introduced on each pixel.

2.1.1. Normal mode

The theoretical normal-mode transmission for a rectangular carrier phase with $\pm 2\pi A$ fluctuation was shown to be $|\cos(2\pi A)|^2$ in [1]. The actual transmission deviates, however, from the theoretical prediction. The theoretical and measured transmission curves are shown in Fig. 2. The transmission loss from the SLM's reflectivity (93%) was not included in the calculation or measurements. The plot of blue circles is the theoretical prediction, whereas the colored solid lines are the transmissions measured at three different carrier frequencies by varying the carrier amplitude (A) from 0 to 1 wave. The transmission at each carrier frequency was averaged over nine different points on the SLM. The black, blue, and red solid lines correspond to the carrier periodicity of two, four, and six pixels, respectively. The measured transmission curves show discrepancies with the theoretical curve in which the location of the first minimum is farther away from the theoretical 0.25 and the second peak is lower than 1. Another theoretical transmission curve based on a sinusoidal carrier is shown by the plot of purple circles. The analytic transmission function of a sinusoidal carrier is a Bessel function (J_0). Comparison of the analytic and measured transmission curves shows that the measured transmission has characteristics somewhere between the rectangular and sinusoidal carriers. The deviation from the rectangular-carrier transmission curve becomes larger as the carrier frequency increases. This suggests that the corners of the actual carrier wave are rounded and this effect becomes more pronounced at high frequency. Based on this observation, the empirical transmission function can be expressed using both cosine and Bessel functions as follows:

$$T(A) = (1 - c)[(1 - a) \cos(2\pi bA) + aJ_0(2\pi bA)]^2 + c, \quad (3)$$

where T is the transmission as a function of carrier amplitude A . The fit parameters (a , b , c) for each averaged transmission curve are given in Table 1. The numerically fit transmission functions are shown as dashed lines in Fig. 2.

The locations of the first minima calculated from the analytic function with the given fit parameters are shown in the A_{min} column. The minimum transmission is the same as c . The value of c is shown to the fourth digit to emphasize the fact that there is a low level of leak even at “zero” transmission. The extinction is better at a lower carrier frequency.

Table 1

Rectangular-carrier transmission parameters. The transmission of the two-pixel (px)-period carrier is fit over $0 < A < 1$. The fit range for four-pixel- and six-pixel-period carriers is $0 < A < 0.6$.

Carrier period	a	b	c	A_{\min}
2-px period	0.64	0.80	0.0015	0.40
4-px period	0.39	0.95	0.0006	0.30
6-px period	0.23	0.97	0.0001	0.28

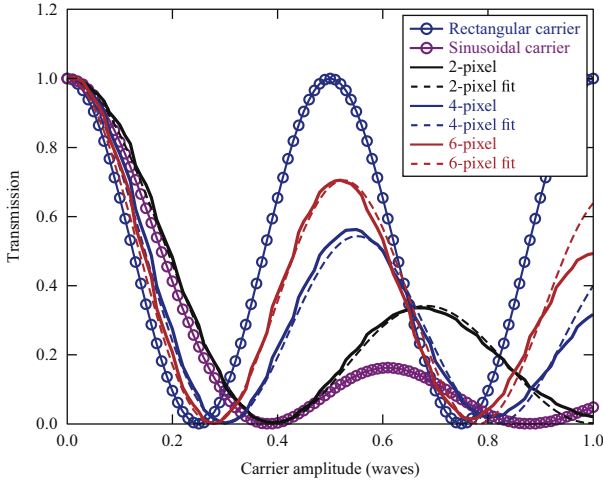


Fig. 2. Transmission curve with respect to varying wavefront amplitude. The six-pixel-period carrier transmission is closer to that of the rectangular carrier and the two-pixel-carrier transmission is closer to the sinusoidal carrier transmission. There is a finite extinction due to scattering. (For interpretation of the references to color in this figure caption, the reader is referred to the web version of this paper.)

The choice of carrier frequency depends on beam-shaping applications. The six-pixel-period carrier requires a smaller carrier wavefront amplitude than the two-pixel carrier (0.28 versus 0.40) to achieve maximum contrast, leaving the rest of the dynamic range for wavefront correction. On the other hand, the two-pixel-period carrier allows more digital levels per unit transmission change, therefore a finer beam-shaping scale.

2.1.2. Diffractive mode

The transmission characteristic of the diffractive-mode beam shaping using a sawtooth carrier is shown in Fig. 3. The transmission with respect to the blazed-grating amplitude was measured at different grating periods. Each curve was averaged over nine different points on the SLM. The analytic transmission function for a sawtooth carrier is

$$T(A) = \Gamma \left\{ \frac{\sin[2\pi(A-0.5)]}{2\pi(A-0.5)} \right\}^2, \quad (4)$$

where Γ is the diffraction efficiency and $2A$ is the p-v of the sawtooth carrier. Γ is lower than 1 because the sawtooth shape is pixelated in LCOS-SLM. As in the case of the rectangular carrier, the analytic transmission function does not agree well with the measured transmission, albeit the discrepancy is smaller in this case. We find that the following empirical expression, made of trigonometric and Bessel functions similar to Eq. (3), fits the data better than the analytic function:

$$T(A) = c[(1-a) \sin(2\pi bA) + aJ_2(2\pi bA)]^2. \quad (5)$$

The fit parameters (a , b , c) are summarized in Table 2.

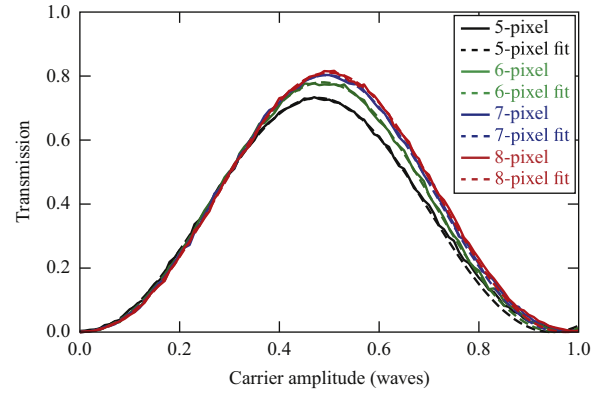


Fig. 3. Transmission characteristic of the diffractive-mode carrier.

Table 2

Sawtooth-carrier transmission parameters. The curves were fit over $0 < A < 0.7$.

Carrier period	a	b	c	A_{\max}	T_{\max}
5-px period	0.52	0.61	1.88	0.48	0.73
6-px period	0.65	0.65	2.60	0.49	0.78
7-px period	0.69	0.66	2.89	0.50	0.80
8-px period	0.70	0.67	3.00	0.50	0.81

Retaining a high diffraction efficiency is important for a diffractive mode. Fig. 3 suggests that the maximum transmission reaches 81% with an eight-pixel carrier but does not improve much beyond that. The carrier frequency cannot be set too low in any case because the first- and zeroth-order diffractions must be angularly separated. The effective spatial resolution is also reduced with a large period carrier. As in the rectangular carrier setup, the 93% reflectivity of the device was not included in the measurement. The actual maximum throughput is 75% for the eight-pixel carrier.

The fit parameters in either normal or diffractive mode must be recharacterized whenever there is a change in the design of the LCOS chip, such as the fill factor.

2.2. Closed-loop algorithm

Based on the quasi-linear response of the SLM to command voltage, a general form of a 2-D command map $C(x,y)$ including wavefront shaping $[W(x,y)$, bias of carrier] and transmission control $[A(x,y)$, envelope of carrier, same as A in Eqs. (3), (5)] can be written as

$$C(x,y) = \gamma[W(x,y) + A(x,y) \times (\text{carrier})], \quad (6)$$

or

$$C(x,y) = C_W(x,y) + C_A(x,y) \times (\text{carrier}), \quad (7)$$

where the spatial frequency of $W(x,y)$ should be smaller than that of the carrier, γ is a conversion factor from wavefront unit to command voltage, and C_W and C_A are the command maps corresponding to W and A , respectively. Because of the small local variations in the phase retardation at a constant voltage across the device, $C(x,y)$ producing the required $W(x,y)$ and $A(x,y)$ cannot be exactly determined in a single step. A closed-loop algorithm is required to improve the result. A variant of the Newton method and a closed-loop algorithm based on that method will be discussed.

the carrier envelope command voltage is

$$C_{A,1} = T_0^{-1}(T_{\text{obj}}),$$

$$C_{A,n+1} = C_{A,n} - \frac{1}{(dT/dC_A)_{\text{max}}} [T(C_{A,n}) - T_{\text{obj}}]. \quad (14)$$

The constant search derivative $(dT/dC_A)_{\text{max}}$ is to be understood as a negative value smaller than the infimum of dT/dC_A in the case of normal-mode beam shaping or a positive value larger than the supremum of dT/dC_A in the case of reverse beam shaping. In either case, the valid interval of C_A is from zero to $C_{A,\text{min}}$ or $C_{A,\text{max}}$. $C_{A,\text{min}}$ and $C_{A,\text{max}}$ are the command voltages corresponding to A_{min} and A_{max} shown in Table 1 and 2. The inversion function T_0^{-1} is numerically calculated.

Since the fluence is the quantity measured directly, it is more useful to express the above iteration formula in terms of fluences. Since the objective fluence map, F_{obj} , is $T_{\text{obj}} \times F_{\text{init}}$ where F_{init} is the initial fluence map,

$$C_{A,1} = T_0^{-1}(F_{\text{obj}}/F_{\text{init}}),$$

$$C_{A,n+1} = C_{A,n} - \frac{1}{(dT/dC_A)_{\text{max}}} [F(C_{A,n}) - F_{\text{obj}}]/F_{\text{init}}. \quad (15)$$

The iteration does not start if $|F_{\text{init}}| < \epsilon$ or $|F_{\text{init}} - F_{\text{obj}}| < \epsilon$ since it suggests that either there is no beam to shape or there is no need to shape. C_A locally corresponding to these conditions is fixed at 0 for normal mode or at $C_{A,\text{max}}$ for diffractive mode. The iteration stops if $|F(C_{A,n}) - F_{\text{obj}}| < \epsilon$ or if $C_{A,n} > C_{A,\text{min}}$ for normal mode or if $C_{A,n} < 0$ for diffractive mode. The second criterion is needed when F_{obj} is specified to be much smaller than that the system can handle. For example, the minimum transmission of a rectangular carrier can be a few percent high for a certain LCOS-SLM model with a low fill factor, while the objective transmission can be ideally set to 0%. Unable to reach the solution, the iteration will keep increasing $C_{A,n}$ past the minimum (same as A_{min} in Table 1). Setting an upper limit to $C_{A,n}$ will prevent this runaway situation.

Eqs. (12) and (15) can be rewritten using gain parameters (g_W and g_A) that are positive and smaller than 1:

$$C_{W,n+1} = C_{W,n} + g_W[W_{\text{obj}} - W(C_{W,n})], \quad (16)$$

and

$$C_{A,n+1} = C_{A,n} \pm g_A[F(C_{A,n}) - F_{\text{obj}}]/F_{\text{init}}, \quad (17)$$

where positive and negative signs in front of g_A correspond to normal and diffractive modes, respectively.

3. Application in gain precompensation for a Nd:glass amplifier

The multi-terawatt (MTW) laser at the Laboratory for Laser Energetics of the University of Rochester consists of an OPCPA front end and two glass amplifiers [10]. The OPCPA front end consists of three OPA stages, one before, and two after the stretcher. The preamplification before the stretcher improves the pulse contrast [11]. The two OPA stages after the stretcher amplify the pulse up to ~ 200 mJ. The first main amplifier after the OPCPA front end is a 25-mm-diam Nd:glass rod amplifier (RA) in a double-pass configuration. The second main amplifier is made of four 400-mm-aperture disks installed in a zig zag formation at the Brewster angle. The 200-mJ pulse from the OPCPA front end is amplified to 2 J through the rod amplifier and can be boosted up to 120 J by four passes through the disk amplifier. The amplified pulse is then compressed and sent to the target chamber. The schematic of the whole system is shown in Fig. 6(a). The spatial light modulator (SLM) is placed between the OPCPA front end output and the rod amplifier at an image plane. A more-detailed schematic of this part of the system is shown in Fig. 6(b). The square output beam from the OPCPA front end is anamorphically imaged to the rectangular area of the SLM (see Section 2.1). It is restored back to the original square beam by double passing the same anamorphic imaging system. A static phase corrector in front of the SLM cancels the intrinsic wavefront error in the SLM [2]. The beam is shaped to a gain-precompensated profile by the SLM using the normal-mode carrier method. After the SLM, the beam is switched out by polarization optics and imaged to the exit surface of the rod amplifier. On double passing the rod amplifier, the amplified pulse is magnified and imaged to the disk amplifier. A sample of the injection beam to the disk amplifier is picked off by an uncoated mirror blank and imaged to a wavefront sensor.

The anamorphic image relay (AIR) is made of two pairs of cylindrical lenses. The outer and inner pairs of cylindrical lenses separately image the horizontal and vertical dimensions with different magnifications. The 13×13 -mm² input beam is transformed into a 12×16 -mm² beam on the SLM. An AIR works for only a fixed object distance. The error in the object distance is recovered by adjusting the image distance, but only in one dimension in an AIR. The tolerance in object positioning within which the imaging conditions in horizontal and vertical dimensions remain the same can be derived by using the Maréchal criterion for the defocus term as

$$\Delta z_{\text{obj}} \leq \frac{D^2}{\lambda \Delta M^2}, \quad (18)$$

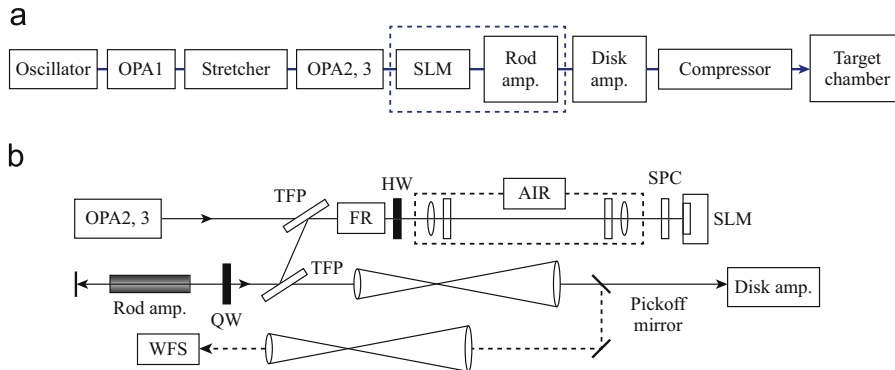


Fig. 6. (a) Overall schematic of the multi-terawatt (MTW) laser; (b) detailed schematic of the MTW beam-shaping system. The image relay shown between the rod amplifier and the disk amplifier is a simplified representation. TFP: thin-film polarizer; FR: Faraday rotator; HW: half-wave plate; QW: quarter-wave plate; SPC: static phase corrector; WFS: wavefront sensor.

where $\Delta M^2 = |M_x^2 - M_y^2|$ and D is the smallest feature size of the object. With a few-hundred-micron feature size in the beam and $\Delta M^2 = 0.66$, the positioning tolerance is tens of millimeters.

The full utilization of the rectangular area of the SLM reduces the peak fluence by 25% and allows for a safer operation below the damage threshold of the SLM. The damage threshold of LCOS samples, which were the same kind as used in the device, was found to be 230 mJ/cm² using the same 2.5-ns OPCA pulses running at 5 Hz. The peak fluence of the anamorphically imaged beam on the SLM at the maximum OPCA energy (200 mJ) does not exceed 160 mJ/cm². The AIR does not require a vacuum system; there is a large separation between the sagittal and tangential focal planes, significantly reducing the intensity near the focus.

The reflection from the anti-reflective-coated first surface of the SLM cover glass introduces a prepulse 30 ps before the main pulse, down at the –40-dB level. This is not acceptable for experiments requiring a high-contrast pulse. The SLM was customized with a wedged cover glass to eliminate the prepulse; the wedge angle is 4.1 mrad. An alternative would be diffractive-mode beam shaping, where the prepulse from the cover glass is automatically separated from the main pulse.

The beam profile at the diagnostic wavefront sensor [WFS in Fig. 6(b)] before and after the amplification in the rod amplifier is shown in Fig. 7. The relatively uniform input OPCA beam profile shown in Fig. 7(a) is highly distorted at the bottom corners after amplification in the rod amplifier [Fig. 7(b)].

Based on the two fluence maps measured before and after the amplification, a gain-precompensated fluence map, or an objective map, can be designed that will become uniform on amplification. Assuming that the objective is a super-Gaussian beam, the objective fluence has the following form:

$$F_{\text{obj}} = F_{\text{peak}} \times F_0 \times T_{\text{gain}}, \quad (19)$$

where F_{peak} is a constant that adjusts the maximum objective fluence and F_0 is a super-Gaussian beam profile usually expressed as

$$F_0 = \exp \left\{ - \left[\left(\frac{x - x_c}{R_x} \right)^m + \left(\frac{y - y_c}{R_y} \right)^m \right] \right\}. \quad (20)$$

T_{gain} is a map of the ratio between the fluences before and after amplification:

$$T_{\text{gain}} = \frac{F_{\text{init}}}{F_{\text{amp}}}, \quad (21)$$

where F_{init} and F_{amp} correspond to Fig. 7(a) and (b), respectively.

The ratio map calculated as above cannot be directly used because it is not well defined where the denominator is close to or equal to zero. A special region of interest is created to avoid this problem and to add stability in a 2-D polynomial fit. The region of interest consists of an interior region and an exterior rectangular frame as shown in Fig. 8. In the interior region (Ω_A) the signal level of both F_{init} and F_{amp} is above 5% of the maximum signal level. The outer region (Ω_B) is a region of the rectangular frame. The coefficients for a set of 2-D Legendre polynomials are calculated to fit the measured gain ratio within the interior region and all zeros in the exterior frame region. The zeros in the frame stabilize the edge of the polynomials. The outer region has dimensions of $2x_0 \times 2y_0$ with the frame thickness dR . There is a no strict rule to setting x_0 , y_0 , and dR . The frame size should be large enough to cover the interior region but not bigger than the camera area; dR should be set thin enough to provide the best numerical fit. The number of modes used in this case was 240. The polynomial representation of T_{gain} is normalized to 1 at the end.

The polynomial fit in combination with the super-Gaussian envelope F_0 provides a smooth objective profile that can be experimentally achieved. In Eq. (19), F_{peak} is a single number that can be adjusted from zero to a few times the maximum of F_{init} ; F_{peak} is set as high as possible to minimize the energy loss from beam shaping.

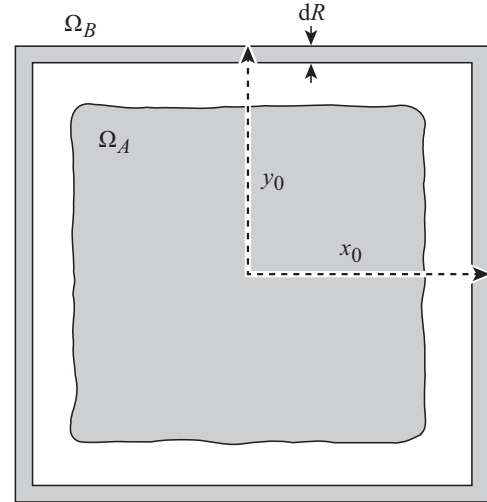


Fig. 8. Region of interest for polynomial fit.

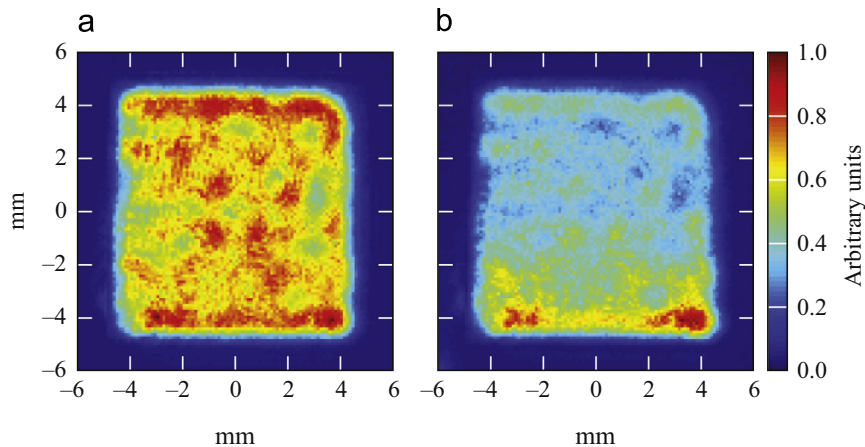


Fig. 7. Beam profile (a) before and (b) after amplification through the rod amplifier. The lower bottom corners of the beam become hot after amplification. The dimensions of the images correspond to camera space in the diagnostic beam path.

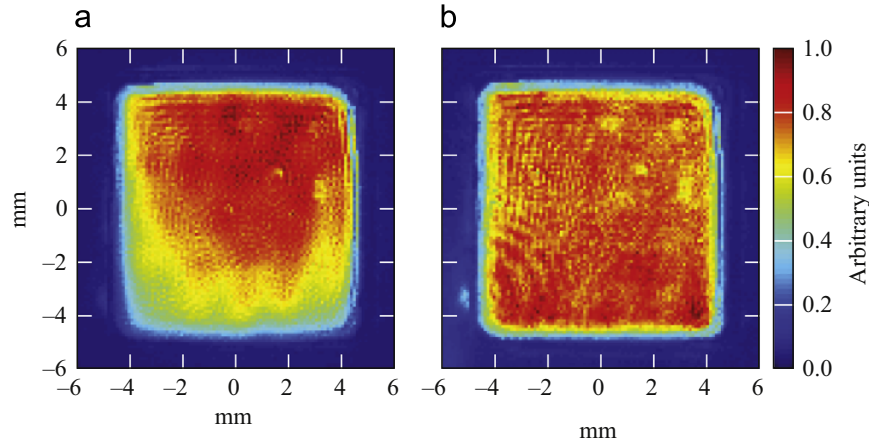


Fig. 9. Precompensated beam profile (a) before and (b) after amplification through the rod amplifier. The lower bottom corners of the beam are attenuated before amplification and become even after amplification.

As a final step, the part of the objective map accidentally set higher than F_{init} is set to F_{init} and set to zero where it is negative. The remaining sharp features are low-pass filtered.

Fig. 9(a) shows the beam-shaping result precompensating the gain nonuniformity in the amplifier shown in Fig. 7(b). The precompensated beam is restored to a flat beam profile after amplification as shown in Fig. 9(b). It takes only half an hour from the measurement of an uncompensated rod amplifier beam to a design of an objective map and a completion of the closed-loop. The beam shape is maintained at near-optimum condition in daily operations by rerunning the closed-loop.

The beam uniformity achieved in the rod amplifier stage is not degraded as the beam passes through the next amplifier, which is the disk amplifier. The profile of a 39-J beam at the output of the disk amplifier near an image plane is shown in Fig. 10. The beam contrast as defined in Eq. (1) of [12] is 9%. Improvement in beam uniformity helps to operate the system under safe conditions by keeping the maximum fluence below the damage threshold of the compressor gratings. The maximum fluence of this beam is 1.1 J/cm^2 whereas the damage threshold of the grating is 1.5 J/cm^2 at 10 ps measured by N-on-1 tests.

We have not seen any pulse compressibility issue coming from the use of SLM for the MTW laser. The amplified pulse width is 700 fs whether using the SLM or bypassing it with a flat mirror. For broadband applications, one can use a metal coated SLM with reduced reflectivity (Hamamatsu X10468-07). As the phase response is slightly different at different wavelengths, the diffraction efficiency cannot be maintained at a single value over a broad bandwidth. This results in the blurring of beam shaping and a reduced contrast. Fig. 2(b) of [13] indicates 0.007 rad/nm change at π phase shift for this type of device. Allowing 0.3 rad tolerance in beam shaping carrier amplitude, the bandwidth of the beam is limited to about 45 nm.

The dispersion of the SLM can be measured using white light interferometry [14]. The total dispersion of the SLM consists of the dispersion in the cover glass and the Gires–Tournois (GT) interference from the liquid crystal layer and its surrounding structure such as the semi-transparent conducting layer and alignment layers. The double passing of the 3-mm thick cover-glass introduces 0.7 rad of spectral phase from 750 to 1000 nm after removing the quadratic term. The spectral phase of the GT interference in the broadband SLM sample (X10468-07) has modulation of 0.05 rad in p–v with 24 nm periodicity in off-state. The spectral and temporal responses of similar LCOS-SLM's in on-state were characterized in [15] using different methods. The p–v of the GT modulation there was shown to be 0.15 rad with 45-nm

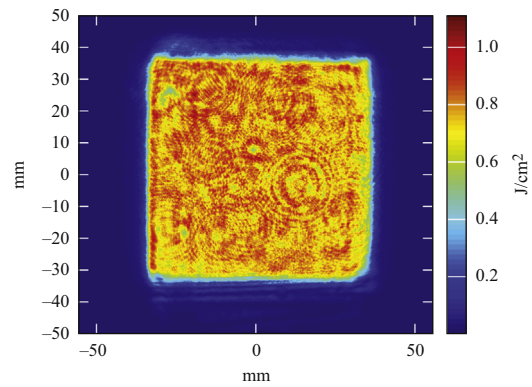


Fig. 10. Beam profile of the disk-amplifier output near an image plane. The energy in the beam is 39 J and the full-width-at-half-maximum is 70 mm.

periodicity at the full gray level. This level of modulation creates small pre- and post-pulses only visible in logarithmic scale and does not affect the main pulse. More importantly, the temporal diffraction from the steep edge of the spectrum is more dominant than the weak pre/post-pulses from the GT etalon effect because the broadband spectrum usually has a super-Gaussian like shape.

4. Conclusions

The previous carrier-beam-shaping method using an SLM has been improved in both open-loop and closed-loop algorithms. The improvements to the open-loop algorithm are based on using a measured transmission function rather than a theoretical function. The measured function can still be expressed as a simple analytic function with three parameters specific to the device and the carrier type. A new search method dubbed as the constant maximum-derivative Newton method improves the closed-loop algorithm in terms of convergence stability and speed. The details of both wavefront- and fluence-shaping closed-loop algorithms were summarized in Eqs. (16) and (17). A new method of carrier-beam-shaping using a sawtooth carrier and the first order diffraction as the main beam was explored. It has a fail-safe feature and higher beam contrast, which might be useful in some applications.

The beam-shaping system was implemented in a multiterawatt OPCPA laser. The gain precompensation of a 200-mJ, 2.5-ns OPCPA laser beam improves the beam uniformity of the next-stage amplification. The objective map for the precompensation is designed based on pre- and post-amplification beam profiles.

The improved uniformity in the precompensated amplified beam is striking in which it is better than the unamplified OPCPA input beam. The improved uniformity in the amplified beam through the rod amplifier with the help of beam shaping allows for a safer energy ramp in the next-stage boost amplifier and a better protection of the gratings in the pulse compressor. The best beam shape can be maintained thanks to the dynamic adjustability of the beam shaper regardless of the small daily changes in the OPCPA beam profile and the gain response in the rod amplifier.

Other important issues were also addressed in applying the SLM-based beam shaping system to a high-energy laser. The device can be run safely below the damage threshold even at full OPCPA energy by utilizing the entire available SLM area. This is done by anamorphically imaging a square input beam onto the rectangular area of the SLM. The prepulse coming from the SLM's front surface, which adversely affects a solid-target experiment, was eliminated by using a customized wedged cover glass.

With future improvements in the damage threshold and the bandwidth of a liquid crystal device that can be used with the carrier-beam-shaping method, a beam-shaping system similar to the one described in this paper may find a broader application in improving laser performance.

Acknowledgments

This paper is based on the work supported by the Department of Energy National Nuclear Security Administration under Award Number DE-NA0001944, the University of Rochester, and the New York State Energy Research and Development Authority. The

support of DOE does not constitute an endorsement by DOE of the views expressed in this paper.

References

- [1] V. Bagnoud, J.D. Zuegel, *Opt. Lett.* 29 (2004) 295.
- [2] S. Bahk, E. Fess, B.E. Kruschwitz, J.D. Zuegel, *Opt. Express* 18 (2010) 9151.
- [3] M. Barcys, S.-W. Bahk, M. Spilatro, D. Coppenbarger, E. Hill, T.H. Hinterman, R.W. Kidder, J. Puth, T. Touris, J.D. Zuegel, *Proc. SPIE* 8602 (2013) 86020F-86020F-12.
- [4] C. Dorrer, J.D. Zuegel, *J. Opt. Soc. Am. B* 24 (2007) 1268.
- [5] J. Heebner, M. Borden, P. Miller, S. Hunter, K. Christensen, M. Scanlan, C. Haynam, P. Wegner, M. Hermann, G. Brunton, E. Tse, A. Awwal, N. Wong, L. Seppala, M. Franks, E. Marley, K. Williams, T. Budge, M. Hennesian, C. Stolz, T. Suratwala, M. Monticelli, D. Walmer, S. Dixit, C. Widmayer, J. Wolfe, J. Bude, K. McCarty, J.-M. DiNicola, *Proc. SPIE* 7916 (2011) 79160H.
- [6] S. Bahk, J.D. Zuegel, J.R. Fienup, C.C. Widmayer, J. Heebner, *Appl. Opt.* 47 (2008) 6586.
- [7] M.J. Guardalben, L.J. Waxer, *Proc. SPIE* 7916 (2011) 79160G.
- [8] T. Zhao, J. Yu, C. Li, K. Huang, Y. Ma, X. Tang, Z. Fan, *J. Mod. Opt.* 60 (2012) 109.
- [9] S. Ngcobo, I. Litvin, L. Burger, A. Forbes, *Nat. Commun.* 4 (2013) 2289. <http://dx.doi.org/10.1038/ncomms3289>.
- [10] V. Bagnoud, J. Puth, I. Begishev, M. Guardalben, J.D. Zuegel, N. Forget, C.L. Blanc, J. Bromage, A multiterawatt laser using a high-contrast, optical parametric chirped-pulse preamplifier, in: *Conference on Lasers and Electro-Optics/Quantum Electronics and Laser Science and Photonic Applications Systems Technologies*, Optical Society of America, 2005, p. JFA1.
- [11] C. Dorrer, I.A. Begishev, A.V. Okishev, J.D. Zuegel, *Opt. Lett.* 32 (2007) 2143.
- [12] C.A. Haynam, P.J. Wegner, J.M. Auerbach, M.W. Bowers, S.N. Dixit, G.V. Erbert, G.M. Heestand, M.A. Hennesian, M.R. Hermann, K.S. Jancaitis, K.R. Manes, C.D. Marshall, N.C. Mehta, J. Menapace, E. Moses, J.R. Murray, M.C. Nostrand, C.D. Orth, R. Patterson, R.A. Sacks, M.J. Shaw, M. Spaeth, S.B. Sutton, W.H. Williams, C.C. Widmayer, R.K. White, S.T. Yang, B.M.V. Wonterghem, *Appl. Opt.* 46 (2007) 3276.
- [13] H. Huang, T. Inoue, H. Tanaka, *Opt. Express* 19 (2011) 15026.
- [14] S. Diddams, J.-C. Diels, *J. Opt. Soc. Am. B* 13 (1996) 1120.
- [15] M. Bock, S.K. Das, R. Grunwald, S. Osten, P. Staudt, G. Stibenz, *Appl. Phys. Lett.* 92 (2008) 151105.